

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 7,111,385 B2  
APPLICATION NO. : 10/675126  
DATED : September 26, 2006  
INVENTOR(S) : Chau et al.

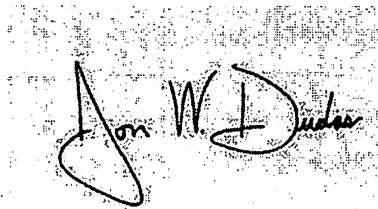
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It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Col. 9, Line 27: "layer silicon" should read -- layer and the silicon --  
Col. 9, Line 31: "layer thickness" should read -- layer with a thickness --  
Col. 10, Line 14: "lay thickness" should read -- layer with a thickness --

Signed and Sealed this

Thirtieth Day of January, 2007

A handwritten signature in black ink, appearing to read "Jon W. Dudas", is written over a rectangular area with a light, textured background.

JON W. DUDAS  
*Director of the United States Patent and Trademark Office*